

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1746

PATENT APPLICATION  
Docket No.: 2522-042  
Client Ref. No.: AW8122US/PJ

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Eun-Taek YIM, et al.

Serial No.: 10/734,479 Examiner: Chaudry, Saeed T.

Filed: December 12, 2003 Art Unit: 1746

Confirmation No.: 9601

For: METHOD FOR CLEANING A DEPOSITION CHAMBER AND  
DEPOSITION APPARATUS FOR PERFORMING IN SITU  
CLEANING

Date: November 20, 2006

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

Responsive to the Final Office Action, Paper No. 20060914, dated September 18, 2006,  
please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2  
of this paper.

**Remarks** begin on page 7 of this paper.